



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/977,158
Filing Date: October 11, 2001
Applicant: Lai et al.
Group Art Unit: 1763
Examiner: Sylvia R. MacArthur
Title: Wafer Thinning Techniques
Attorney Docket: 4675-000373

Director of The United States Patent and Trademark Office
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*OK'd to enter
in 2/16/04*

AMENDMENT

Sir:

In response to the Office Action mailed January 8, 2004, please amend the application as follows and consider the remarks set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 2 of this paper.